## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

**Art Unit: 3723** 

Kajiwara et al. Serial No. 09/874,174 Examiner: MORGAN, Eileen P. Attorney Docket No. A-70092/RMA

Filed: June 4, 2001

Date: December 13, 2004

For:

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POLISHING APPARATUS AND
METHOD HAVING A RETAINING
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**SURFACE** 

## PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. 1.136(a), a petition for an extension of time of (1) one month is hereby requested to respond to the Office Action mailed August 12, 2004.

The Commissioner is hereby authorized to charge any additional fees or credit any overpayment to Deposit Account No. 50-2319 (Order No. <u>A-70092/RMA</u>).

Respectfully submitted,

12/17/2004 DTESSEM1 00000015 502319 09874174

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**DORSEY & WHITNEY LLP** 

By:

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal
Service with Sufficient postage as firs class mail in an envelope addressed to
COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450, on this date:

Typed or printed name

R. MICHAEL ANANIAN

Signature

\*\*Commissioner\*\*

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